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Application No. 09/582,049

OCT 28 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In Re Patent Application | : | Group Art Unit: 1754 |
| Garnier, <i>et al.</i> | : | |
| Serial Number: 09/582,049 | : | Examiner: Nguyen, Ngoc Yen M. |
| | : | |
| Filed: September 1, 2000 | : | Attn. Docket No.: Garnier-1 |
| | : | |
| Title: Silicon Refining Method and Installation | : | Date: October 28, 2005 |
| | : | |

Commissioner for Patents
Washington, D.C. 20231**AMENDMENT AND RESPONSE**

Sir:

This paper is responsive to the Office Action dated September 10, 2002. A Renewed Petition under 37 CFR 1.137(b) requesting reconsideration of the decision mailed on June 28, 2005, which dismissed applicants' May 23, 2005 petition for revival of an application abandoned unintentionally, is included herewith. Also included herewith is a petition for a two (2) month extension of time to extend the due date for filing the Renewed Petition to October 28, 2005 and a request for continued examination. Kindly enter the following amendments:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.